

OptoFlat Low Coherence Interferometer

Designed for production quality control and incoming quality assurance of polished flat optical components

Key Features:

- Turn-key system with integrated stage
- Measures thin plan-parallel polished surfaces
- Easy to use, 4 or 6 inch aperture downward looking, rigid platform
- High throughput, vibration isolation table not required
- High resolution, low distortion 1x and 4x optical zoom
- Low coherence, no spurious backside fringes
- High reliability LED light source at 633nm
- Polish process development
- Sub-nanometer precision



For further information please contact support@trioptics-berlin.com.